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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CON of PCT/JP02/09734 09/20/2002

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2001-299435 09/28/2001

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	JAPAN	5	24	7
Examiner's Signature <i>LV</i> Initials				

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## TITLE

Silicon substrate etching method and etching apparatus

FILING FEE	RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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